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GEMOLOGICAL  
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 30, 2024

IGI Report Number

LG649472557

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

8.51 X 5.97 X 4.09 MM

GRADING RESULTS

Carat Weight

2.04 CARATS

Color Grade

D

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence


NONE

Inscription(s)

 LG649472557

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

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
Symmetry

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Fluorescence

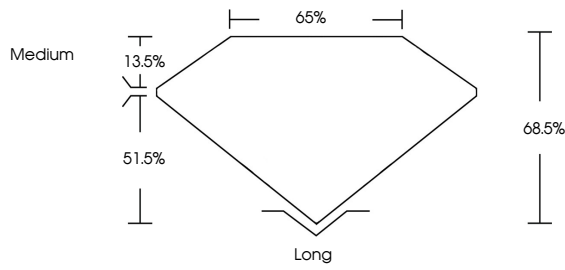
NONE

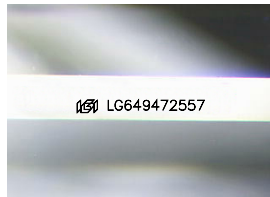
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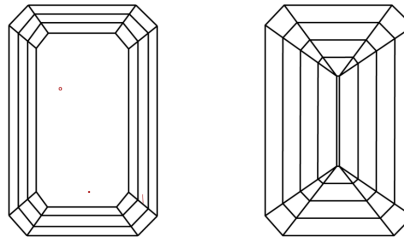
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VS <sup>1-2</sup> VS <sup>1-2</sup> SI <sup>1-2</sup> I <sup>1-3</sup>

Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included



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EMERALD CUT

8.51 X 5.97 X 4.09 MM

Carat Weight

2.04 CARATS

Color Grade

D

Clarity Grade

VS 1

Depth

68.5%

Table

65%

Girdle

Medium

Culet

Long

Polish

EXCELLENT


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